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| SERIAL NUMBER 10/509,230 | FILING OR 371(c) DATE 09/24/2004 RULE | CLASS 250 | GROUP ART UNIT 2881 | ATTORNEY DOCKET NO. SON-2628 |
| APPLICANTS Shinji Omori, Kanagawa, JAPAN; Kaoru Koike, Ibaraki, JAPAN; Shigeru Moriya, Kanagawa, JAPAN; Isao Ashida, Kanagawa, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/03455 03/20/2003 | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2002-92612 03/28/2002 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 08/16/2005 | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____ | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 24 | TOTAL CLAIMS 26 |
| | | | | INDEPENDENT CLAIMS 5 |
| ADDRESS 23353 | | | | |
| TITLE Mask pattern correction method, production method of semiconductor device, mask production method and mask | | | | |
| FILING FEE RECEIVED 1500 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |